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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

NO

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 024719/2003 01/31/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 18	TOTAL CLAIMS 28	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	Verified and Acknowledged	Examiner's Signature	Initials	

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 21254  
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TITLE  
 Method of fabricating semiconductor device using Plasma-Enhanced CVD

☐ All Fees